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Chih Chich Yeh et al.

PTO/NB/08A (08-00)

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First Named Inventor

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Group Art Unit Douglas W. Owens Examiner Name MXIC 1553-3

2 Attorney Docket Number Sheet

			U.S. PATENT DOC	JMENTS	
Examiner nitials*	Cite No.1	U.S. Putent Document Number (d known)	Name of Patenties or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Rolevant Passages or Relevant Figures Acpear
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			APPLICANT	First Named Inventor	Chih Chich Yeh et al.
			AI I BIOAITI	Group Art Unit	2811
	(use as mai	ny sheets	as necessary)	Examiner Name	Douglas W. Owens
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